

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In Re Patent Application:** : **Group Art Unit:** 1744  
Ming-Chun Chou :  
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**Serial Number:** 10/823,955 : **Examiner:** Karls, Shay Lynn  
:  
**Filed:** April 14, 2004 : **Confirmation No.:** 5433  
:  
**Title:** Brush Positioning Device For A Wafer : **Attorney Docket No.:** N1161-00026  
Cleaning Station :

Mail Stop Amendment  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**ELECTION**

Sir:

This paper is responsive to the Office Action mailed on May 24, 2007 in the above-captioned application. Kindly enter the following:

**Remarks** begin on page 2 of this paper.